IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

Gurtej S. Sandhu and Sujit Sharan

Serial No.:

Filed:

November 12, 1999

For:

METHOD FOR IN-SITU CLEANING OF

INDUCTIVELY-COUPLED PLASMA CHAMBERS

Group Art Unit:

Examiner:

Atty. Docket: 95-0392.02

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, Applicants respectfully request that this Information Disclosure Statement be entered and that the references listed on the attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed references are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. § 1.97(b), this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possible material information as defined in 37 C.F.R. § 1.56(a) exists.

The following references are submitted for the Examiner's review:

U.S. Patents

U.S. Patent No.	Issue Date	inventor

5,824,607	10/20/98	Trow et al.
5,817,534	10/06/98	Ye et al.
5,812,403	09/22/98	Fong et al.

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5,792,272	08/11/98	van Os et al.
5,788,799	08/04/98	Steger et al.
5,788,778	08/04/98	Shang et al.
5,614,055	03/25/97	Fairbairn et al.
5,514,246	05/07/96	Blalock
5,409,563	04/25/95	Cathey .
5,393,709	02/28/95	Lur et al.
5,389,496	02/14/95	Calvert et al.
5,389,195	02/14/95	Ouderkirk et al.
5,384,289	01/24/95	Westmoreland
5,368,687	11/29/94	Sandhu et al.
5,252,518	10/12/93	Sandhu et al.
5,240,739	08/31/93	Doan et al.
4,878,994	11/07/89	Jucha et al.
4,820,377	04/11/89	Davis et al.
4,795,880	01/03/89	Hayes et al.

Other References:

"Advanced Plasma Sources: What's Working?," Semiconductor International, pp. 56-58, 60, May 1994.

Applicants understand that no fee or certification is required for the submission and consideration of this information at this time.

If there are any matters which may be resolved or clarified through telephone interview, the Examiner is respectfully requested to contact Applicants' undersigned attorney at the number indicated.

A Form PTO-1449 is enclosed herewith.

Respectfully submitted,

Date: 11/12/99

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ATTORNEY FOR APPLICANTS

Sheet: 1 of: 1

FORM: PT@ 1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

Atty Docket No:
95-0392.02

Applicant:
Sandhu, et al.

Group:

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(37°CFR 1.98(b))

(use several sheets if necessary)

Filing Date: November 12, 1999

U.S. PATENT DOCUMENTS

Examiner		Document	Dete	N.		0.1.1	
Initial		Number -	Date	Name	Class	Subclass	
h	AA	5,824,607	10/20/98	Trow et al.	438	732	
	AB	5,817,534	10/06/98	Ye et al.	438	10	
	AC	5,812,403	09/22/98	Fong et al.	364	468.28	
	AD	5,792,272	08/11/98	van Os et al.	118	723 IR	· · · · · · · · · · · · · · · · · · ·
	AE	5,788,799	08/04/98	Steger et al.	156	345	
	AF	5,788,778	08/04/98	Shang et al.	134	001	
	AG	5,614,055	03/25/97	Fairbairn et al.	156	345	
	AH	5,514,246	05/07/96	Blalock	156	643.1	
	AI	5,409,563	04/25/95	Cathey	156	643	
	AJ	5,393,709	02/28/95	Lur et al.	437	228	
	AK	5,389,496	02/14/95	Calvert et al.	430	315	
	AL	5,389,195	02/14/95	Ouderkirk et al.	156	643	
	AM	5,384,289	01/24/95	Westmoreland	437	245	
	AN	5,368,687	11/29/94	Sandhu et al.	156	664	
	AO	5,252,518	10/12/93	Sandhu et al.	437	200	
	AP	5,240,739	08/31/93	Doan et al.	427	126.1	-
	AQ	4,878,994	11/07/89	Jucha et al.	156	643	
	AR	4,820,377	04/11/89	Davis et al.	156	643	
	AS	4,795,880	01/03/89	Hayes et al.	219	121.52	

FOREIGN PATENT DOCUMENTS

	Examiner		Document		•			Trans	lation
	Initial		Number	Date	Country	Class	Subclass	Yes	No
		AT	,						
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· Initial		OTHER ART (including author, title, date, pertinent pages, etc.)					
	AV	"Advanced Plasma Sources: What's Working?," Semiconductor International, pp. 56-58, 60, May 1984					
	AW						
	AX						

Examiner:	Date Considered:

EXAMINER:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication with applicant.